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August 10, 2006

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Applicants: Chunyuan Chao, Kuei-Chang Tsai and George A. Kovall  
Assignee: Mosel Vitelic, Inc.  
Title: DYNAMICALLY CONTROLLABLE REDUCTION OF VERTICAL CONTACT DIAMETER THROUGH ADJUSTMENT OF ETCH MASK STACK FOR DIELECTRIC ETCH

Application No.: 10/718,320 Filed: November 19, 2003  
Examiner: Deo, Duy Vu Nguyen Group Art: 1765  
Docket No.: M-15208 US Confirmation No.: 1058

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (1 page in duplicate); and
- (3) Amendment After Final (15 pages).

- ☒ No additional fee is required.  
☐ The fee has been calculated as shown below:

## CLAIMS AS AMENDED

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	30	Minus	37	=	0	x \$50.00	\$ 0.00
Independent Claims	3	Minus	4	=	0	x \$200.00	\$ 0.00
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input type="checkbox"/>	Fee for Request for Extension of Time						\$ 0.00

### Total additional fee for this Amendment:

\$

- ☒ Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- ☒ Please charge our Deposit Account No. 50-2257 in the amount of \$ 0.00
- ☒ Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$ 0.00

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 10, 2006.

Attorney for Applicant(s)

8-10-06

Date of Signature

Respectfully submitted,

Gideon Gimlan  
Attorney for Applicants  
Reg. No. 31,955



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Chunyuan ("Luis") Chao et al  
Assignee: Mosel-Vitellic, Inc.  
Title: Dynamically Controllable Reduction of Vertical Contact Diameter  
Through Adjustment of Etch Mask Stack for Dielectric Etch  
Application No.: 10/718,320 Filing Date: 11/19/2003  
Examiner: Deo, Duy Vu Nguyen Group Art Unit: 1765  
Docket No.: M-15208-US Confirm No.: 1058

San Jose, California  
August 10, 2006

M/S AF  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

AMENDMENT AFTER FINAL

Dear Sir:

In response to the Final Office Action having a mailing date of May 19, 2006, please  
amend the application as set forth below.

**Claims Listing** begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.